

AUG 12 2008

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To:	Examiner Amanda C. Walke	From:	Timothy N. Trop
Company:	US Patent Office	Date:	August 12, 2008
Fax:	(571) 273-8300	Pages:	5 (including cover sheet)
Your Re:	10/688,521	Our Re:	ITL.1026US

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In re Applicant:	Robert P. Meagley et al.	§	Art Unit:	1795
Serial No.:	10/688,521	§	Examiner:	Amanda C. Walke
Filed:	October 17, 2003	§	Docket:	ITL.1026US P16713
For:	Reducing Photoresist Line Edge Roughness Using Chemically- Assisted Reflow	§	Assignee:	Intel Corporation

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO FINAL REJECTION

Sir:

In response to the final rejection mailed June 27, 2008, reconsideration is requested in view of the following remarks.

A current listing of the claims is attached. No amendments were made to the claims.

Date of Deposit: August 12, 2008
I hereby certify that this document is being facsimile transmitted to the
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